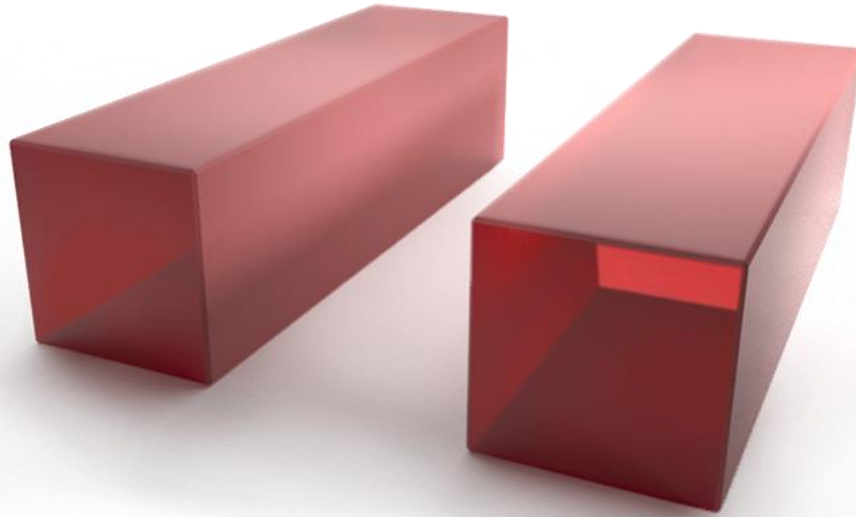




# OPTOGAMA



# Ti:SAPPHIRE LASER CRYSTAL

WHITE PAPER

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Titanium-doped sapphire ( $\text{Ti}^{3+}:\text{Al}_2\text{O}_3$ ) has a very large gain bandwidth (670-1070 nm) in combination with excellent thermal conductivity and is used for ultrashort pulse generation and widely wavelength-tunable lasers.

The absorption and emission spectra of Ti:Sapphire crystal are shown in Fig.1., and the basic spectroscopic and thermomechanical properties are summarized in Table 1.

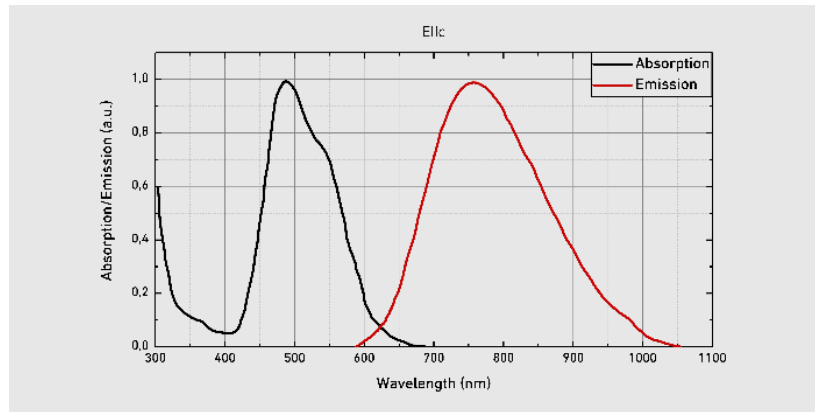


Fig. 1. Absorption and emission spectra of Ti:Sapphire



IMG 1. Examples of Ti:Sapphire crystal blanks

Table 1 SPECTROSCOPIC AND THERMOMECHANICAL PROPERTIES of Ti:Al<sub>2</sub>O<sub>3</sub>

Absorption peak wavelength	488 nm
Absorption cross-section at peak wavelength	$3.8 \times 10^{-19} \text{ cm}^2$
Laser wavelength	790 (670-1070) nm
Lifetime of energy level	3,2 $\mu\text{s}$
Emission cross-section @790 nm	$4.1 \times 10^{-19} \text{ cm}^2$
Refractive index @800 nm	1,76
Crystal structure	hexagonal
Density	3,98 g/cm <sup>3</sup>
Mohs hardness	9
Thermal conductivity	33 Wm <sup>-1</sup> K-1
dn/dT	$13 \times 10^{-6} \text{ K}^{-1}$
Thermal expansion coefficient	$5 \times 10^{-6} \text{ K}^{-1}$
Typical doping level	0,05-0,3 at.%

## PUMPING SOURCES FOR Ti:SAPPHIRE LASERS

Pumping sources for Ti:Sapphire lasers include frequency-doubled diode-pumped Nd lasers, frequency-doubled fiber lasers and optically pumped semiconductor lasers (OPSL). The development of high-power InGaN-based semiconductor diode lasers has opened new possibilities for pumping Ti:Sapphire lasers. InGaN diode lasers can greatly reduce the complexity, size, and cost of Ti:Sapphire systems. Guidance on optimizing designs for InGaN diode-pumped Ti:Sapphire lasers can be found in reference [1], which considers some unexpected behavior, particularly with 450 nm pumping.

## FEATURES OF Ti:SAPPHIRE LASER CRYSTALS FROM OPTOGAMA

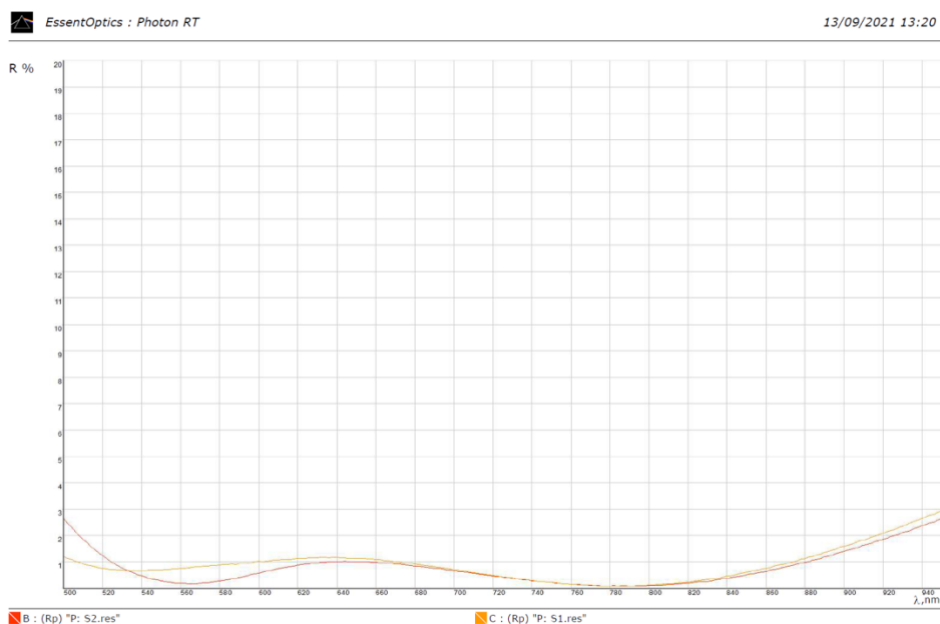
- Titanium doping is from 0,05 to 0,3 at. %;
- Absorption coefficient is from 0,2 to 7,5 cm<sup>-1</sup>@532 nm (E//c axis);
- FOM is from 150 (for high doped material) to >200 (for low doping material). The boule is annealed under strongly reducing atmosphere to achieve good balance between Ti<sup>3+</sup> and Ti<sup>4+</sup> ions;
- We have option to use corrective MRF polishing technique to improve transmitted wavefront distortion to <λ/4@632,8 nm;
- The standard surface quality is 10-5 S-D, controlling precise dimensional tolerances;
- Large size up to 110 x 110 x 40 mm.

## ANTIREFLECTION COATINGS

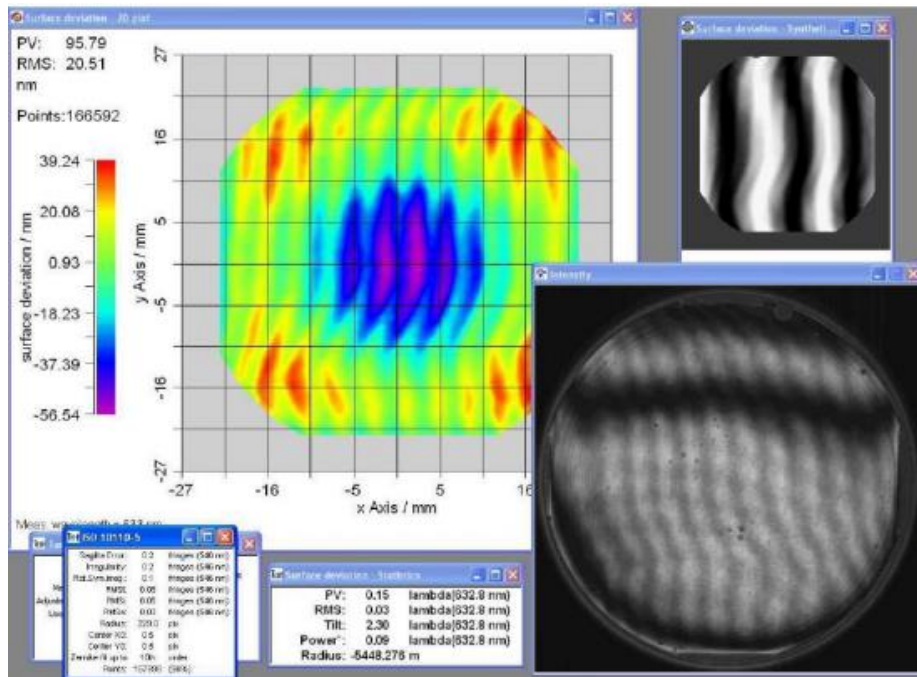
- Narrow band and broadband designs;
- Coating design and deposition technique are adopted for vacuum and cryogenic temperature environment;
- Laser induced damage threshold:

>7 J/cm<sup>2</sup> @ 532 nm; 5 ns; 10 Hz;

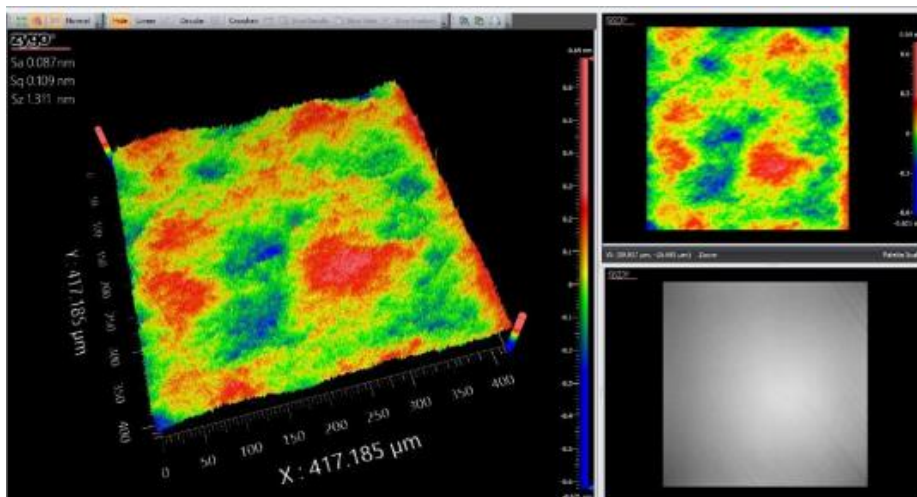
>2 J/cm<sup>2</sup> @ 800 nm; 300 ps; 10 Hz.



IMG 2. Broadband coating



IMG 3. Interferogram of large 50x50mm Ti:Sapphire crystal flatness



IMG 4. Surface roughness (<math><1\text{\AA}</math> PV) measurement result of our standard 06 x 20 mm crystal

## References

1. PETER F. MOULTON, JEFFREY G. CEDERBERG, KEVIN T. STEVENS, GREG FOUNDOS, MICHAL KOSELJA, AND JANA PRECLIKOVA4 „Optimized InGaN-diode pumping of Ti:Sapphire crystals“, Optical Materials Express, 2019, Vol.9, No 5, PP.2131-2146.



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